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***Nanoengineering: Fabrication,  
Properties, Optics, and  
Devices XIII***

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# Contents

vii	<i>Authors</i>
ix	<i>Conference Committee</i>

---

## SESSION 1 NANOPHOTONICS

---

9927 02	<b>Guided-mode resonance nanophotonics: fundamentals and applications (Invited Paper)</b> [9927-1]
9927 04	<b>Self-organized, effective medium black silicon antireflection structures for silicon optics in the mid-infrared</b> [9927-3]
9927 06	<b>Design and fabrication of titanium dioxide wire grid polarizer for the far ultraviolet spectral range</b> [9927-5]
9927 07	<b>Silicon nanowire photodetectors made by metal-assisted chemical etching</b> [9927-6]

---

## SESSION 2 INNOVATIVE PATTERNING

---

9927 08	<b>Nanofabrication of low extinction coefficient and high-aspect-ratio Si structures for metaphotonic applications</b> [9927-8]
9927 09	<b>Dual-width plasmonic gratings with sub-10 nm gaps for biosensor applications</b> [9927-9]

---

## SESSION 3 ENERGY HARVEST

---

9927 0C	<b>Conversion of infrared light into usable energy</b> [9927-12]
9927 0E	<b>Modified Richardson-Dushman equation and modeling thermionic emission from monolayer graphene</b> [9927-14]
9927 0F	<b>Active control of nano dimers response using piezoelectric effect</b> [9927-20]

---

## SESSION 4 METROLOGY AND PRECISION

---

9927 0G	<b>Nanomanufacturing concerns about measurements made in the SEM Part V: dealing with noise (Invited Paper)</b> [9927-15]
9927 0I	<b>Scanned laser inspection of SOI wafers for HVM</b> [9927-17]
9927 0K	<b>Characterization of one-dimensional gratings fabricated by laser-focused atomic deposition</b> [9927-19]

9927 0M **Fabrication and characterization of one-dimensional multilayer gratings for nanoscale microscope calibration** [9927-22]

---

**SESSION 5 NANOENGINEERED MATERIALS**

---

9927 0R **Tapered optical fiber tip probes based on focused ion beam-milled Fabry-Perot microcavities** [9927-27]

---

**SESSION 6 NANODEVICE ENGINEERING**

---

9927 0V **Nanofabrication and test of novel diffractive optics for OAM-mode division multiplexing in optical fibers** [9927-31]

9927 0W **Design and fabrication of Fourier spectral filter array for multispectral imaging** [9927-32]

---

**SESSION 7 NANO-OPTIC DEVICES**

---

9927 0Z **Improved optical enhancement in binary plasmonic gratings with nanogap spacing** [9927-35]

9927 11 **Surface characterization of nanostructured 'black silicon' using impedance spectroscopy** [9927-37]

9927 12 **Characterization of random anti-reflecting surface structures and their polarization response at off-normal angles of incidence** [9927-38]

9927 13 **Holographic imaging with single pixel sensor** [9927-39]

---

**SESSION 8 NANOSTRUCTURE PROPERTIES**

---

9927 15 **Silver nanorod structures for metal enhanced fluorescence** [9927-41]

9927 16 **Modeling thermionic emission from carbon nanotubes with modified Richardson-Dushman equation** [9927-43]

---

**POSTER SESSION**

---

9927 1B **Photovoltaic effects as the physical basis of a new generation of microelectromechanical sensors and systems (MEMS)** [9927-48]

9927 1I **Growth technique and effect of post growth annealing on the optical properties of In(Ga)As/GaAs quantum dot heterostructures** [9927-55]

9927 1J **A detailed investigation of the impact of varying number of dot layers in strain-coupled multistacked InAs/GaAs quantum dot heterostructures** [9927-56]

- 9927 1K **High resolution measurement of water levels in optical components** [9927-57]
- 9927 1M **Cliché fabrication method using precise roll printing process with 5 um pattern width**  
[9927-59]
- 9927 1N **A characterization method for the metal thin film** [9927-60]
- 9927 1Q **Ion-assisted evaporation of vanadium dioxide thin films** [9927-63]
- 9927 1R **Raman spectral analysis of high efficiency PVDF: nanocomposite films doped with MWCNT**  
[9927-64]
- 9927 1S **Induced changes in refractive index, optical band gap, and absorption edge of polycarbonate-SiO<sub>2</sub> thin films by Vis-IR lasers** [9927-66]
- 9927 1T **Excitation of silicon microspheres resonances with femtosecond laser fabricated glass waveguides** [9927-67]